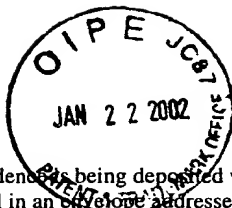


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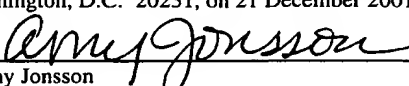
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Amy Jonsson

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Christophe Pierrat et al.)

Application No.: 09/972,428)

Filed: 5 October 2001)

Title: **EXPOSURE CONTROL FOR PHASE
SHIFTING PHOTOLITHOGRAPHIC
MASKS**)

Group Art Unit: 2812

Examiner: Not yet assigned

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner of Patents
Washington, D.C. 20231

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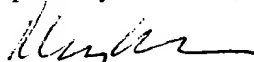
Please change the firm name in the mailing address from "Numerical c/o Haynes Beffel & Wofield LLP" to - - **Numerical c/o Haynes Beffel & Wolfeld LLP** - -.

Please change the name of the first inventor from "Christopher Pierrat" to - - **Christophe Pierrat** - -.

Please change the name of the second inventor from "Michael Luc Cote" to - - **Michel Luc Cote** - -.

Since the error was not caused by applicant, but by the Patent Office, no fee is believed necessary. However, the Commissioner is hereby authorized to charge any additional fees which may be required by this paper, or to credit any overpayment to Deposit Account No. 50-0869 (NMTI 1002-4). This paper is submitted in duplicate.

Respectfully submitted,



Date: 18 December 2001

Mark A. Haynes
Registration No. 30,846

NUMERICAL C/O:
HAYNES BEFFEL & WOLFELD LLP
P.O. Box 366
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Phone: (650) 712-0340



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/972,428	10/05/2001	2812	1538	NMTI 1002-4	6	55	5

CONFIRMATION NO. 3974

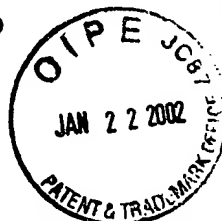
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Applicant(s)

Christophe → Christophe Pierrat, Santa Clara, CA;
Michel → Michael Luc Cote, San Jose, CA;

Domestic Priority data as claimed by applicant

THIS APPLN CLAIMS BENEFIT OF 60/296,788 06/08/2001
AND CLAIMS BENEFIT OF 60/304,142 07/10/2001

HAYNES BEFFEL & WOLFELD LLP

NOV 14 2001

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Foreign Applications

If Required, Foreign Filing License Granted 11/08/2001

Projected Publication Date: 12/12/2002

Non-Publication Request: No

Early Publication Request: No

Title

Exposure control for phase shifting photolithographic masks

Preliminary Class

438

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TC 2002-01-11-1011
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